

Attorney Docket N

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Serial No.:

Doak et al.

09/887,777

Filed: Title:

June 22, 2001

Group Art Unit: 2822

Examiner: Ken Pierre

Method and Apparatus for Preparing Nitride Semiconductor Surfaces

## RESPONSE TO RESTRICTION REQUIREMENT

Responsive to the Election/Restriction Requirement dated July 1, 2002, applicant elects Group II, Claims 12 - 18 and 36-38 drawn to Semiconductor device fabrication, classified in class 257, subclass 760. The Commissioner is authorized to charge any fee required by this paper to Deposit Account No. 07-0135.

Respectfully submitted,

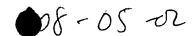
Dated: Eliloz

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## CERTIFICATE OF MAILING BY EXPRESS MAIL Express Label No. EL919123213US

Commissioner for Patents Washington, D.C. 20231

Dear Sir:

I hereby certify that this correspondence, consisting of this Certificate of Mailing by Express Mail, Response to Restriction Requirement and a return-receipt postcard are being deposited in the United States Postal Service as Express Mail in an envelope addressed to:

Commissioner for Patents Washington, D.C. 20231

on

Data

GALLAGHER & KENNEDY, P.A. Attorneys at Law 2575 East Camelback Road Phoenix, Arizona 85016-9255 Tel. No. (602) 530-8000 Suzanne Shields

AUG - 7 2002
TECHNOLOGY CENTER 2800